



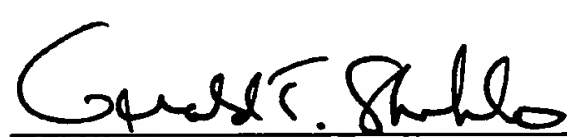
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IFW 1722 ✓

PATENT
Attorney Docket No. 1110/82821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|----------------------------------|---|---|
| In Re U.S. Patent Application |) | Confirmation No.: 6761 |
| |) | |
| Applicant: Kozo Nakamura, et al. |) | |
| |) | <i>I hereby certify that this correspondence is</i> |
| Serial No.: 09/856,212 |) | <i>being deposited with the United Postal</i> |
| |) | <i>Service as first class mail in an envelope</i> |
| Filed: May 18, 2001 |) | <i>addressed to: Mail Stop AMENDMENT,</i> |
| |) | <i>Commissioner of Patents, P.O. Box 1450,</i> |
| For: PRODUCTION METHOD |) | <i>Alexandria, VA, 22313-1450.</i> |
| FOR SILICON SINGLE |) | |
| CRYSTAL AND |) | <u>June 28, 2006</u> |
| PRODUCTION DEVICE FOR |) | |
| SINGLE CRYSTAL INGOT, |) | |
| AND HEAT TREATING |) | |
| METHOD FOR SILICON |) |  |
| SINGLE CRYSTAL WAFER |) | Gerald T. Shekleton Reg. No. 27,466 |
| |) | |
| Examiner: Matthew J. Song |) | |
| |) | |
| Art Unit: 1722 |) | |

AMENDMENT

Mail Stop AMENDMENT
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Office Action of March 3, 2006 has been carefully reviewed and the following amendments and remarks are made in response thereto.